



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

STW

In re patent application of

David William ABRAHAM, et al.

Serial No.: 10/680,260

Group Art Unit: 2814

Filing Date: October 8, 2003

Examiner: Mai, Anh D.

For: METHOD AND SYSTEM FOR PATTERNING OF MAGNETIC THIN FILMS
USING GASEOUS TRANSFORMATION

**RESPONSE TO FIRST OFFICE ACTION AND
RESTRICTION REQUIREMENT**

Sir:

In response to the Office Action dated January 31, 2004, please consider the following:

INTRODUCTORY COMMENTS

Remarks begin on page 2 of this paper.